



U.S. Express Mail No.: EU721509950US  
Attorney Docket No.: AM-5256-2

#6/A  
12/17/02

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Jeng H. Hwang et al.

SERIAL NO.: 09/747,667

FILED: December 22, 2000

FOR: PLASMA HEATING OF A SUBSTRATE WITH  
SUBSEQUENT HIGH TEMPERATURE ETCHING

§ GROUP ART UNIT: 1765

§

§ EXAMINER: S. Ahmed

§

§

§

§ Attorney Docket No.:

§ AM-5256-2

Date: December 11, 2002

**AMENDMENT "A" UNDER 37 CFR § 1.111**

Hon. Commissioner for Patents  
Washington, DC 20231

Sir:

This Amendment "A" is in response to the Office Action mailed September 11, 2002, having a shortened statutory period for response of December 11, 2002.

Claims 1 - 57 are pending in the application.

RECEIVED  
DEC 17 2002  
TC 1700

**CERTIFICATE OF MAILING UNDER 37 CFR § 1.10**

I hereby certify that this paper is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as U.S. EXPRESS MAIL NO. EU721509950US in an envelope addressed to the: Commissioner for Patents, Box Amendment (With Fee), Washington, DC 20231.

Date: December 11, 2002

  
Shirley L. Church, Reg. No. 31,858